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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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re Application of:

Miyanaga, et al.

Serial No.: 10/045,745

Confirmation No.: 9682

Filed:

October 26, 2001

For:

Cleaning Method for Vapor

Phase Deposition

Appratus, and Vapor Phase Deposition Apparatus

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 1746

Examiner:

Frankie L. Stinson

Atty. Dkt. No. APPM/005750/CPI/L/B/P

CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on September 1, 2005 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

September 21, 2005 Date

Signature

RESPONSE TO OFFICE ACTION DATED JUNE 21, 2005

In response to the Office Action dated June 21, 2005, having a shortened statutory period for response set to expire on September 21, 2005, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/005750/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

The Pending Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 4 of this paper.